

Appl. No. 09/673,005
Response dated June 30, 2003
Reply to Office action of February 28, 2003



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7/15/03
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Emmanuel Hadji et al.

Serial No.: 09/673,005

Filed: November 27, 2000

Title: METHOD FOR FORMING AN OPTICAL SILICON LAYER ON A SUPPORT AND
USE OF SIAD METHOD IN THE PRODUCTION OF OPTICAL COMPONENTS

Examiner: Shamim Ahmed

Docket No.: 33019

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Art Unit: 1765

RESPONSE

(In response to Paper No. 9)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This communication is filed in response to the Office action dated February 28, 2003. The three month period for responding to the Office Action expired on May 28, 2003. Accordingly, applicants respectfully request and petition that the response date be extended, for one month, to June 28, 2003. The \$110.00 extension of time fee is enclosed.

The following remarks are submitted for the Examiner's consideration.

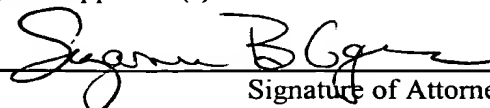
I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Suzanne B. Gagnon

Name of Attorney for Applicant(s)

June 30, 2003

Date



Signature of Attorney

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